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INFORMATION DISCLOSURE CITATION IN AN APPLICATION		APPLICANT: HIATT et al.	
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		GROUP ART UNIT: 3729	
OTHER DOCUMENTS			
Examiner Initials	(Author, Title, Date, Pertinent Pages, etc.)		
WMT	Park et al., "High Current Integrated Microinductors and Microtransformers using Low Temperature Fabrication Processes," <i>SPIE Proceedings</i> Vol. 2920, 1996 International Symposium on Microelectronics, Minneapolis, Minnesota, USA, October 1996.		
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	Ahn et al., "A Planar Variable Reluctance Magnetic Micromotor with Fully Integrated Stator and Coils," <i>Journal of Microelectromechanical Systems</i> , Volume 2, No. 4, pp. 165-173, December 1993.		
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	Yachi et al., "Thin Film Transformer Fabricated by a Dry Process," <i>NTT Review</i> , Volume 4, No. 3, pp. 46-50, May 1992.		
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EXAMINER SIGNATURE	DATE CONSIDERED		7/11/05
EXAMINER: Initial if citation considered, whether or not citation is in conformance with MPEP § 609. Draw line through citation if not in conformance and not considered. Include copy of this form with next communication to the applicant.			

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